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(54) **THERMOELECTRIC DEVICE WITH INTERNAL SENSOR**

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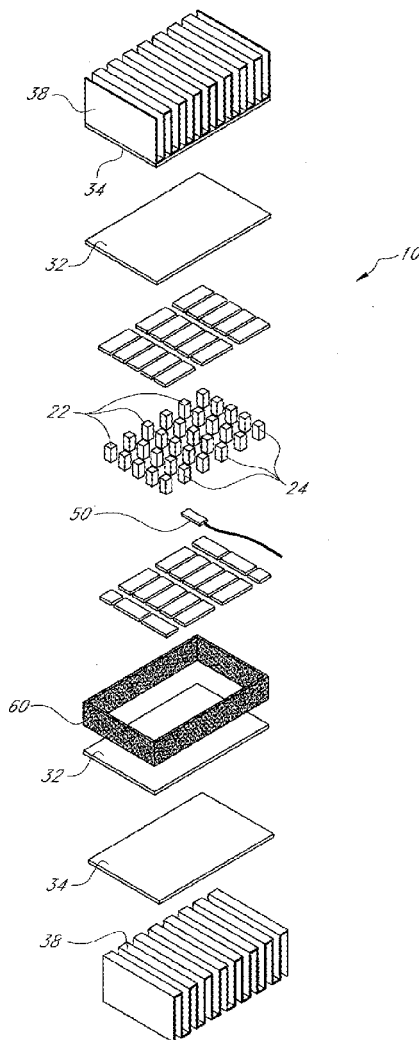
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(57) **ABSTRACT**

A thermoelectric system which comprises two substrates spaced apart from each other to form a gap and a plurality of electrically-connected semiconductor elements disposed between the substrates in the gap. The thermoelectric system further comprises at least one sensor and a seal which extends between the substrates and encloses the sensor and at least one of the plurality of semiconductor elements. The sensor is disposed between the substrates at an interior location spaced from the peripheral edge of at least one of the substrates. Additionally, at least one of the semiconductor elements is disposed between the sensor and the peripheral edge.

Related U.S. Application Data

(63) Continuation of application No. 14/552,130, filed on Nov. 24, 2014, now Pat. No. 9,857,107, which is a continuation of application No. 11/546,928, filed on Oct. 12, 2006, now abandoned.



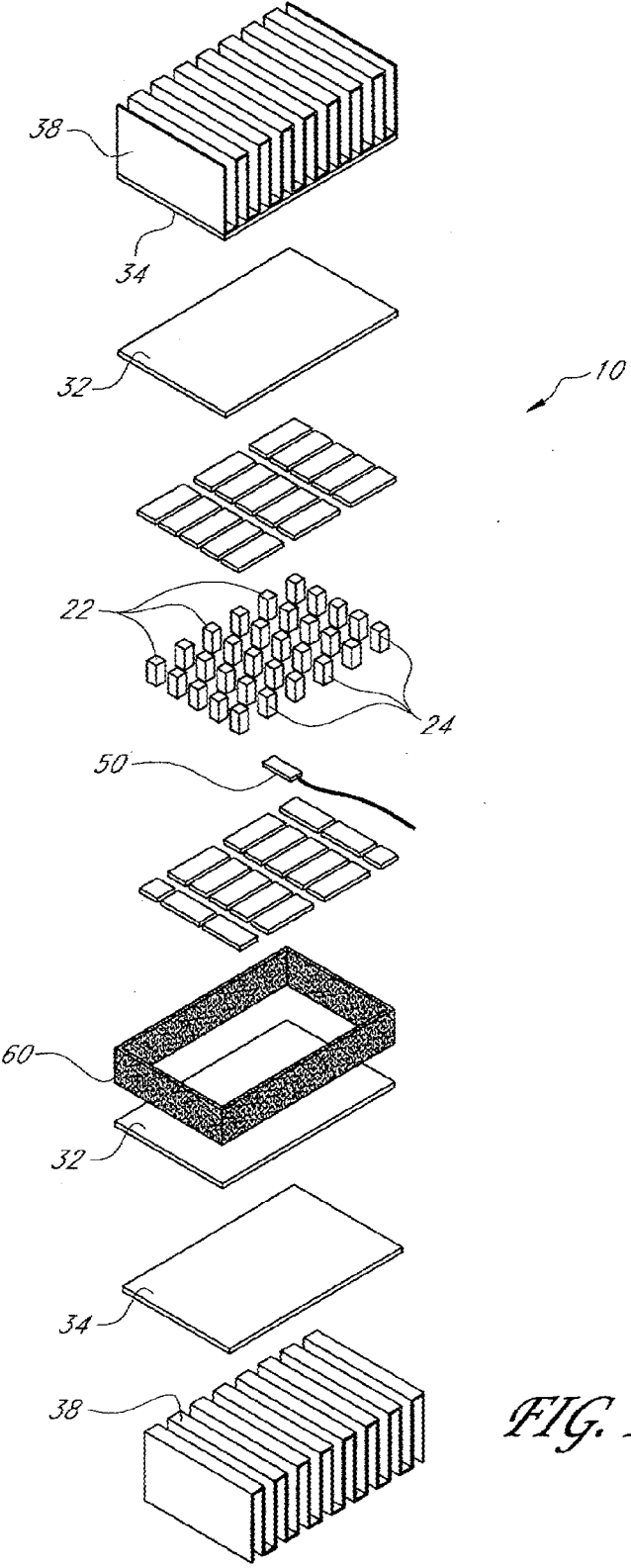


FIG. 1A

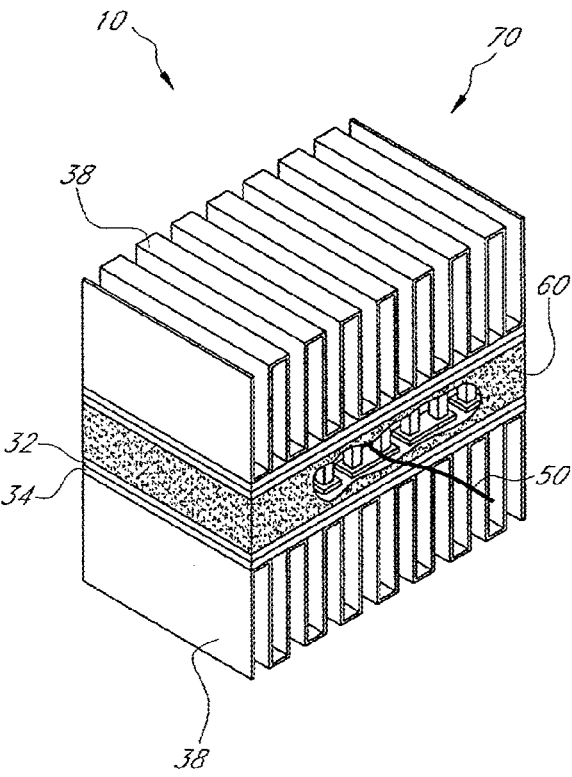


FIG. 1B

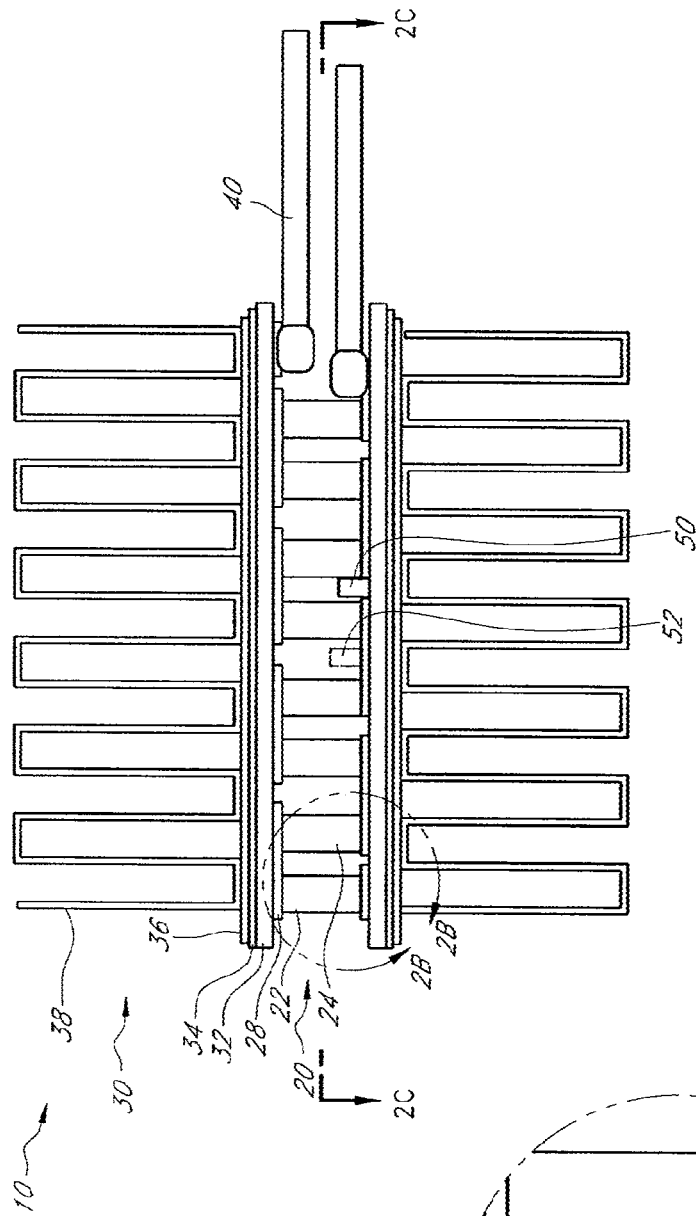


FIG. 2A

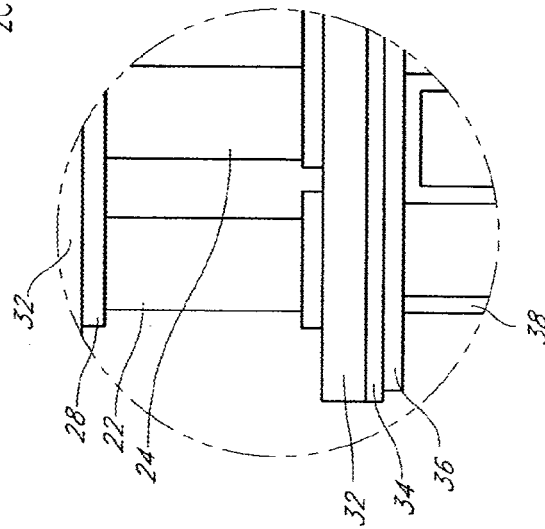


FIG. 2B

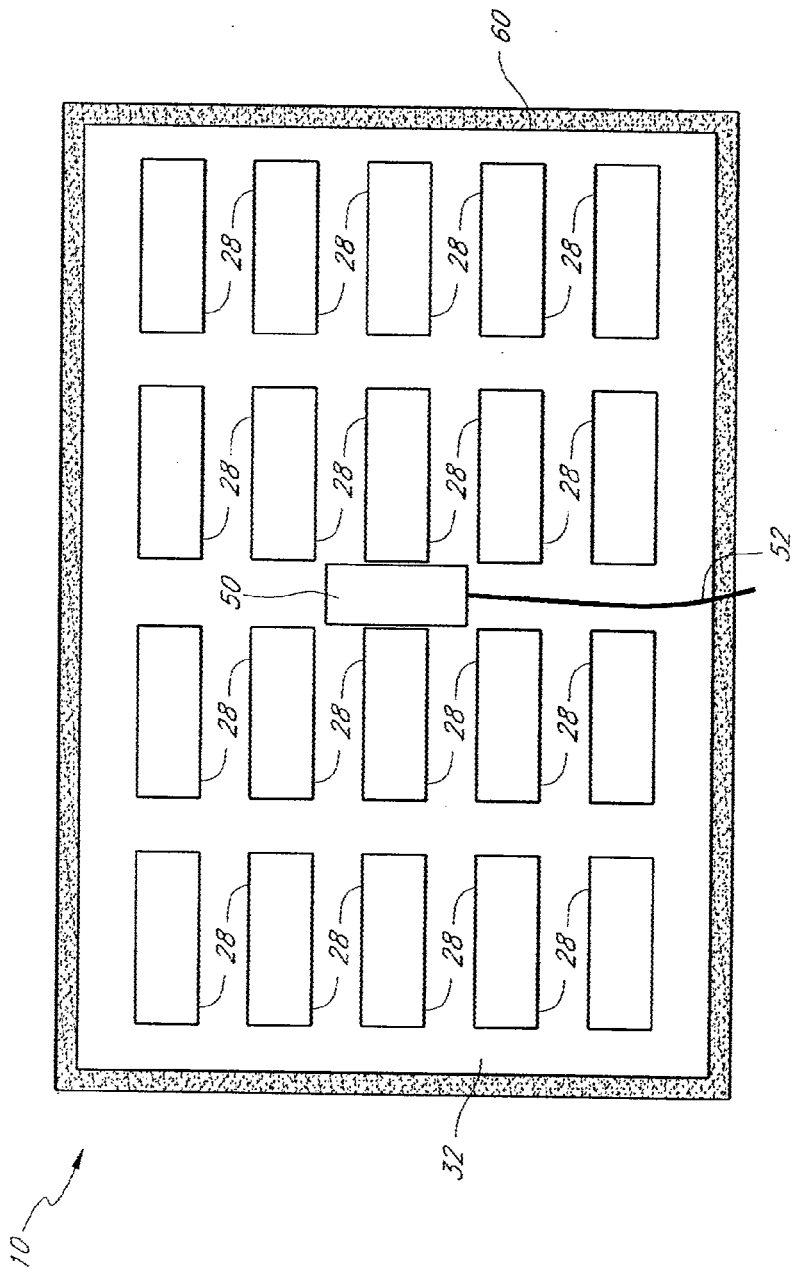


FIG. 2C

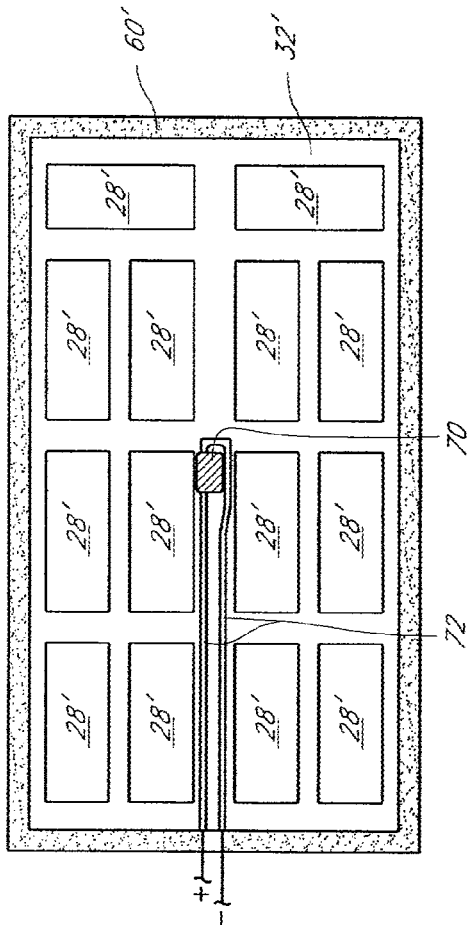


FIG. 20

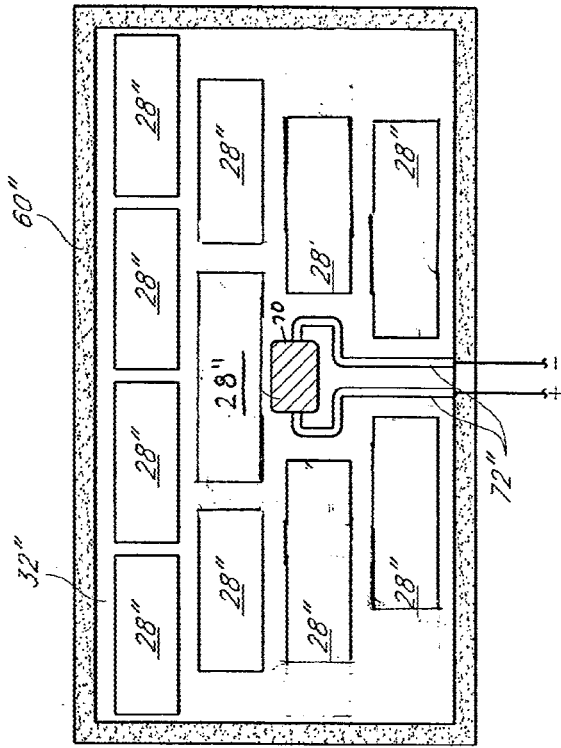


FIG. 21

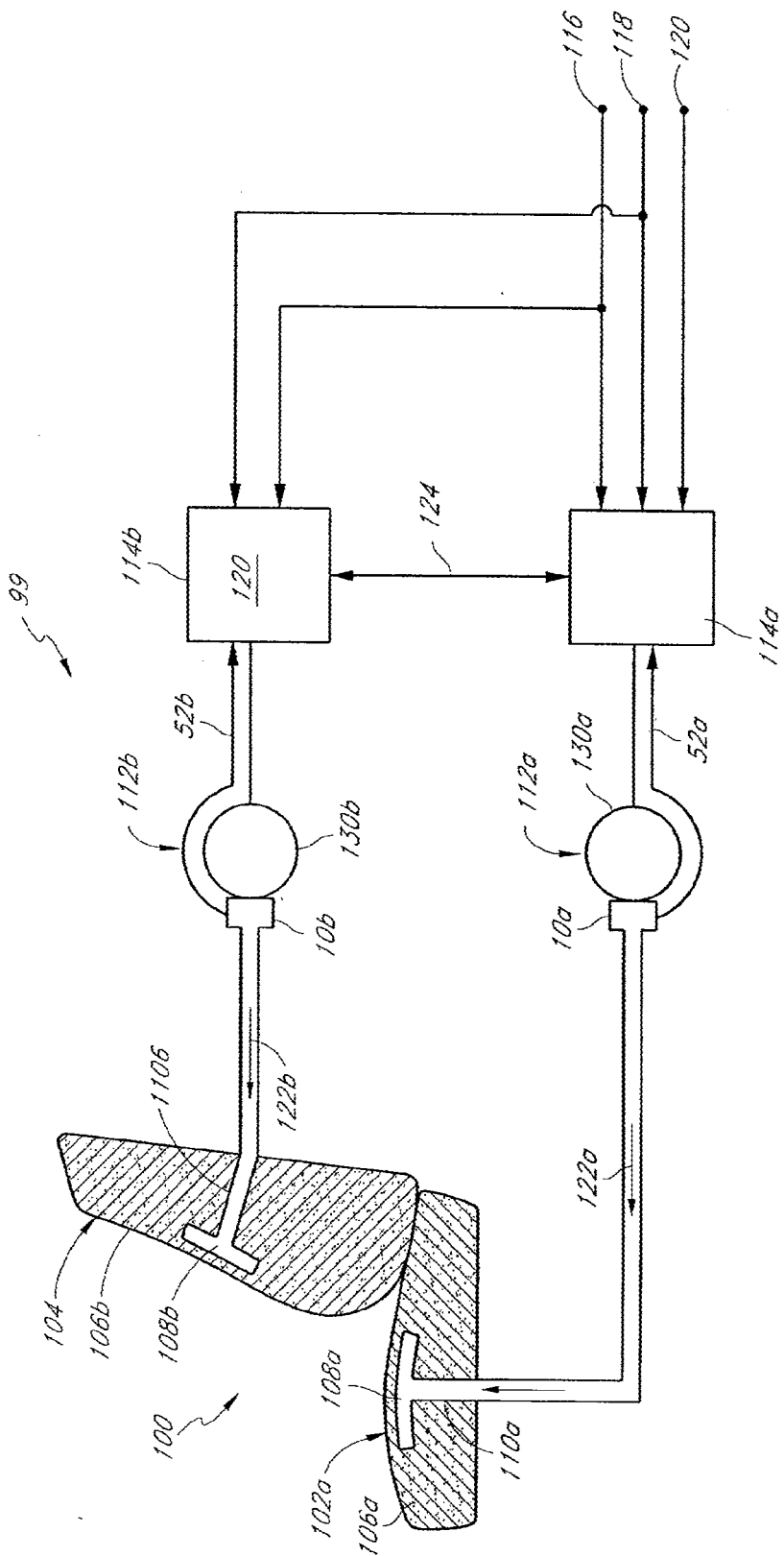


FIG. 3

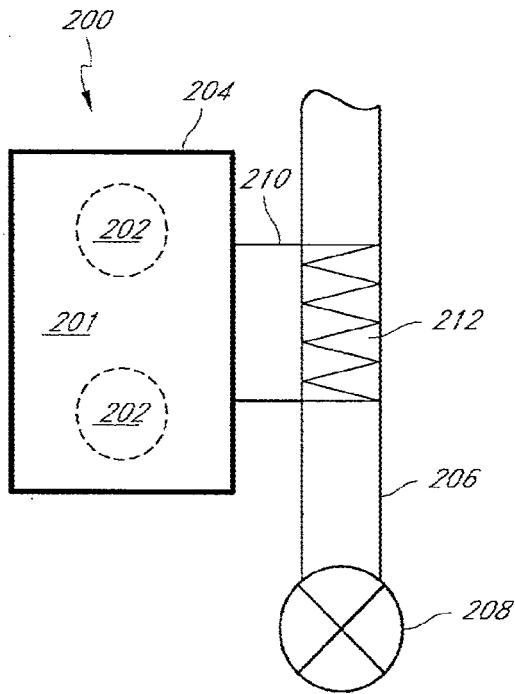


FIG. 4

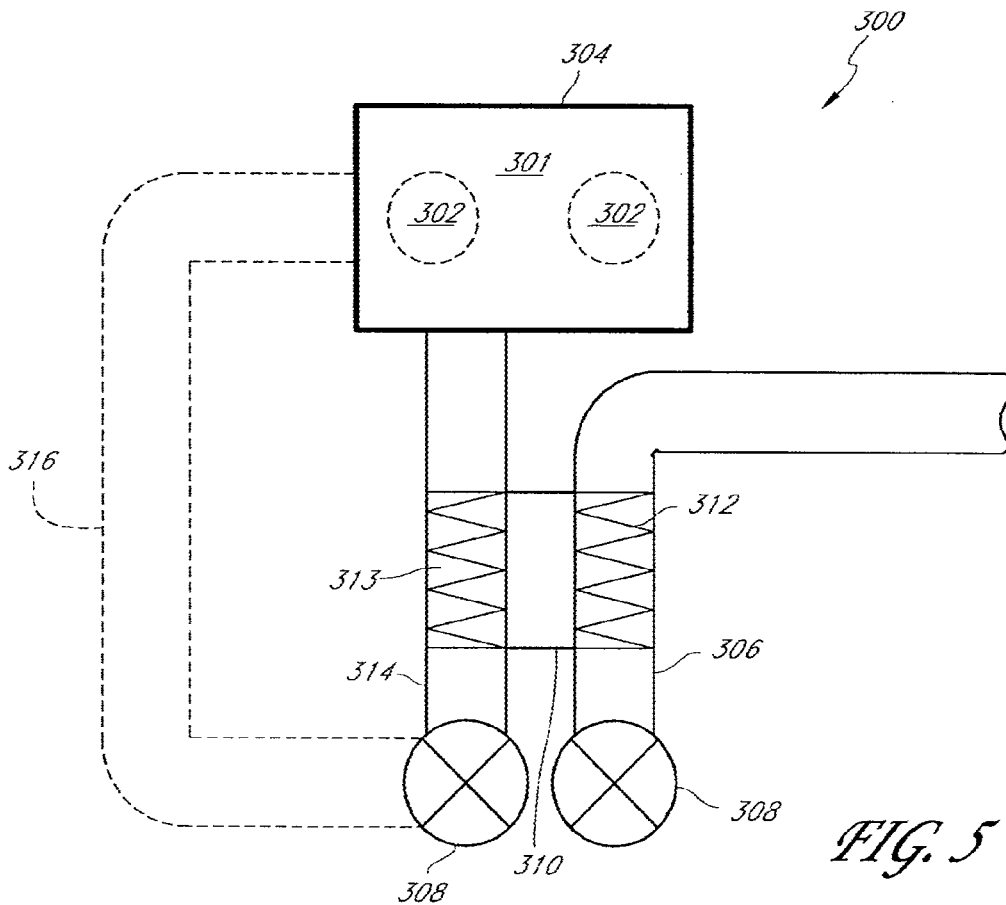


FIG. 5

THERMOELECTRIC DEVICE WITH INTERNAL SENSOR

INCORPORATION BY REFERENCE TO ANY PRIORITY APPLICATIONS

[0001] Any and all applications for which a foreign or domestic priority claim is identified in the Application Data Sheet as filed with the present application are incorporated by reference under 37 CFR 1.57 and made a part of this specification.

BACKGROUND

Field

[0002] The present invention relates generally to thermoelectric devices and, more particularly, to a Peltier circuit.

Description of the Related Art

[0003] A Peltier circuit is a thermoelectric device comprising two sides. When voltage is applied in one direction, one side creates heat while the other side absorbs heat. Switching polarity of the circuit creates the opposite effect. In a typical arrangement, the Peltier circuit comprises a closed circuit that includes dissimilar materials. As a DC voltage is applied to the closed circuit, a temperature change is produced at the junction of the dissimilar materials. Heat is either emitted or absorbed at the junction depending on the direction of current flow. The Peltier circuit can include several such junctions connected electrically in series. The junctions can be sandwiched between two ceramic plates, which form the cold side and the hot side of the device. The cold side can be thermally coupled to an object to be cooled and the hot side can be thermally coupled to a heat sink which dissipates heat to the environment.

[0004] U.S. Patent Publication No. 2006-0130490 (filed Jan. 31, 2005 and published Jun. 22, 2006) discloses a vehicle seat ventilation system that utilizes a Peltier circuit to provide heated and/or cooled air to a vehicle seat for enhancing passenger comfort. Specifically, air can be passed over the cold and/or hot side of the Peltier circuit to heat or cool the air, which is then directed to the vehicle seat. Use of a Peltier circuit is particularly advantageous in this application because the Peltier circuit is compact and allows a single device to provide heated and cooled air to the vehicle seat. That is, the air may be directed over a single surface of the Peltier circuit, and the voltage can be reversed throughout the circuit depending on whether heated or cooled air is desired.

SUMMARY

[0005] U.S. Patent Publication No. 2006-0130490 discloses a climate control system that can include a Peltier circuit for cooling and/or heating air supplied to a vehicle seat. A temperature sensor is used to measure the temperature of the air directed to the vehicle seat. Data from the temperature sensor can be used to control the amount and direction of voltage through the Peltier circuit. The temperature sensor should be reliable and provide accurate measurements. Accordingly, it would be desirable to provide a Peltier circuit with an improved arrangement for protecting the temperature sensor.

[0006] Accordingly, one aspect of the present invention comprises a thermoelectric device that includes a first and a

second substrate spaced apart from each other to form a gap. A plurality of semiconductor elements are disposed between the first and second substrates within the gap. The plurality of semiconductor elements comprise a first group of semiconductor elements having a first set of electrical properties and a second group of semiconductor elements having a second set of electrical properties. A first set of electrical conductors is disposed between the plurality of semiconductors and the first substrate and a second set of electrical conductors are disposed between the plurality of semiconductors and the second substrate. The first set of electrical conductors and the second set of electrical conductors are arranged so the plurality of semiconductor elements are electrically coupled to each other in series with the first and second groups of semiconductor elements in an alternating arrangement. At least one sensor is disposed between the first and second substrates at a location spaced from a peripheral edge of the first and second substrates. A seal extends around the peripheral edge of the first and second substrates.

[0007] Another aspect of the present invention comprises a thermoelectric system that includes a pair of opposing substrates, each substrate having a peripheral edge and a face that generally opposes a face of the other opposing substrate. A plurality of semiconductor elements is positioned between the opposing faces. The plurality of semiconductor elements includes at least two dissimilar semiconductor elements, the plurality of semiconductor elements electrically coupled in series by conductor elements arranged so the two dissimilar elements are connected in an alternating pattern. A sensor is positioned between the pair of opposing substrates at a location spaced from the peripheral edges of the opposing substrates. A seal extends around the plurality of semiconductor elements

[0008] Another aspect of the present invention comprises a climate controlled seat assembly that includes a seat cushion having an outer surface comprising a first side for supporting an occupant in a sitting position and a second side. An air passage extends from the second side into the seat cushion and is configured to deliver air to the first side of the seat cushion. A climate control system is in fluid communication with the air passage. The climate control system includes a thermoelectric device configured to heat and cool air deliver to the air passage. The thermoelectric device includes a pair of opposing substrates. A plurality of semiconductor and connection elements are disposed between the opposing substrates. A sensor is disposed between the pair of opposing substrates. A seal extends around the plurality of semiconductor and connection elements and the sensor.

[0009] Yet another aspect of the present invention comprises a thermoelectric system that includes a pair of opposing substrates, each substrate having a peripheral edge and a face that generally opposes a face of the other opposing substrate. A plurality of semiconductor elements are disposed between the substrates elements. The plurality of semiconductor elements comprises at least two groups of dissimilar semiconductor elements that are alternately electrically coupled to each other in series. A sensor is positioned between the pair of opposing substrates at a location spaced from the peripheral edges of the opposing substrates. The system also includes means for sealing from moisture the plurality of semiconductor elements and the sensor positioned between the pair of opposing substrates.

BRIEF DESCRIPTION OF THE DRAWINGS

[0010] FIG. 1A is an exploded side perspective view of an embodiment of a thermoelectric apparatus;

[0011] FIG. 1B is a side perspective view of the assembled thermoelectric apparatus of FIG. 1A;

[0012] FIG. 2A is a side view of the thermoelectric apparatus of FIG. 1A;

[0013] FIG. 2B is an enlarged view of the portion labeled 2B-2B in FIG. 2A;

[0014] FIG. 2C is a cross-section view taken through line 2C-2C of FIG. 2A with certain portions of the thermoelectric apparatus removed;

[0015] FIG. 2D is a modified embodiment of FIG. 2C;

[0016] FIG. 2E is a modified embodiment of FIG. 2C;

[0017] FIG. 3 is a schematic illustration of a ventilation system that includes the thermoelectric apparatus of FIG. 1A;

[0018] FIG. 4 is a schematic illustration of a conditioned assembly that includes the thermoelectric apparatus of FIG. 1A; and

[0019] FIG. 5 is a schematic illustration of another embodiment of a conditioned assembly that includes the thermoelectric apparatus of FIG. 1A.

DETAILED DESCRIPTION

[0020] FIGS. 1A, 1B, 2A, and 2B illustrate an embodiment of a thermoelectric device 10. FIG. 1A is an exploded view of the thermoelectric device 10 with its various components separated vertically for ease of inspection. FIG. 1B is a side perspective view of the assembled thermoelectric device 10. FIG. 2A is a side view of the thermoelectric device 10 with portions (as explained below) removed. FIG. 2B is an enlarged view of a portion of FIG. 2A.

[0021] With initial reference to FIGS. 1A and 1B, the thermoelectric device 10 can include a plurality of dissimilar conductive elements 22, 24. As will be explained in more detail below, pairs of dissimilar conductive elements 22, 24 can be coupled together by a series 28 of opposing conductor tabs 28, which are, in turn, disposed between a pair of opposing substrates 32. In the illustrated embodiment, each substrate 32 is thermally coupled to a heat transfer member 38 through a thermal conductive element 34. A sensor 50 can be positioned between the opposing substrates 32 and a seal 60 can be provided between the opposing substrates 32 to protect the sensor 50 and the elements between the substrates 32.

[0022] FIGS. 2A and 2B are side views of the thermoelectric device with the seal 60 omitted to allow inspection of the components 22, 24, 28 between the substrates 32. In one embodiment, the dissimilar conductors 22, 24 comprise alternating N-type semiconductor elements 22 and P-type semiconductor elements 24. The N-type semiconductor elements 22 and P-type semiconductor elements 24 can be composed of a bismuth-tellurium alloy (Bi_2Te_3). Other doped or non-doped metals can also be used. The end of each of the N-type semiconductor elements 22 and P-type semiconductor elements 24 can be coated with a diffusion barrier (not shown). The diffusion barrier can inhibit flow of electrons out of the semiconductor elements 22, 24. The diffusion barrier can comprise any of a number of materials, such as, for example, nickel, a titanium/tungsten alloy, and/or molybdenum.

[0023] As can be seen in FIG. 2A, pairs of dissimilar semiconductor elements 22, 24 can be coupled at their tops and bottoms with the conductor elements or tabs 28. Semiconductor elements 22, 24 of the same type are not disposed on the same conductor tab 28. That is, each conductor tab 28 is coupled to only one N-type semiconductor element 22 and only one P-type semiconductor elements 24. In addition, the upper and lower conductor tabs 28 are configured such that the semiconductor elements 22, 24 are disposed in an alternating series. In this manner, the semiconductor elements are electrically connected in series with each other but, with respect to thermal energy, are in parallel with each other.

[0024] With continued reference to FIG. 2A, a first N-type semiconductor element 22 can be coupled at its top to a first conductor tab 28 which can also be coupled to a first P-type semiconductor element 24 to the right of the first N-type semiconductor element 22. At the bottom of the first N-type semiconductor element 22, a second conductor tab 28 can be coupled to the first N-type semiconductor element 22 and can be coupled to a second P-type semiconductor element 24 to be disposed to the left of the first N-type thermoelectric element 22. With reference back to FIG. 1A, the conductor tabs 28 are arranged on the conductor element 28 configured such that all the semiconductor elements 22, 24 are connected in series with each other. It should be appreciated that the conductor tabs 28 can comprise a plurality of discrete elements coupled to the substrate 32 or an intermediate member. In a modified embodiment, the tabs 28 can be formed by tracing or otherwise forming a layer of conductive material on the substrate and/or an intermediate element.

[0025] With continued reference to FIG. 2A, the sensor 50 can be disposed on either substrate 32 between the semiconductor elements 22, 24. As will be explained below, the sensor 50 can be positioned on the substrate 32 between the conductor tabs 28. In dashed lines, FIG. 2A illustrates a sensor 52 in a modified location in which the sensor 52 is positioned on one of the conductor tabs 28.

[0026] As mentioned above, heat transfer assemblies 38 can be positioned on the top and bottom sides of the thermoelectric device 10. The thermoelectric device 10 is capable of operating without the heat transfer assemblies 38, however, the presence of such assemblies 38 increases the efficiency of heat transfer from the thermoelectric device 10 to the ambient atmosphere or a fluid in contact with the thermoelectric device 10.

[0027] With reference to FIGS. 2A and 2B, an electrically-conducting solder (not shown) can be used to mount the N-type semiconductor elements 22 and P-type semiconductor elements 24 to the conductor tabs 28. In one embodiment, the conducting solder can comprise compound of tin and antimony, although other metals or non-metals can be used. In one example, bismuth can also be alloyed with tin to create the solder. Other methods of affixing the semiconductor elements 22, 24 to the conductor tabs 28 can be used, provided an electrical connection is permitted between the semiconductor elements 22, 24 and the conductor tabs 28. In turn, the conductor tabs 28 can suitably be mounted to the substrate 32 via an adhesive.

[0028] The substrates 32 are preferably configured to provide electrical insulation while providing for heat conduction. In one embodiment, the substrates 32 can be constructed of a ceramic material such as, for example,

alumina (ceramic) or silicon. Various other types of materials may be used, such as an epoxy. In such an embodiment, the substrates **32** are preferably sufficiently rigid to maintain the shape of the thermoelectric device **10**. In other embodiments, flexible substrates can be used. When flexible substrates are used, the thermoelectric device can be constructed in various shapes and have the ability to bend from one shape to another. As mentioned above, the substrates **32** can act as an electrical insulator. The typical thickness for a substrate can be between **50** and **500** micrometers, though other thicknesses can be used. In the illustrated embodiment, the substrates **32** can be sufficiently large to cover completely the semiconductor elements **22**, **24** and conductor tabs **28**. The conductor tabs **28** can be coupled to the electrically-insulating substrate **32** through solder, epoxy, or any other mounting mechanism.

[0029] With continued reference to FIGS. 2A and 2B, the heat transfer layer **34** can be disposed between the substrate **32** and the heat transfer member **38**. Accordingly, in the illustrated embodiment, the heat transfer layer **34** can be disposed on the outside of each of the substrates **32**. In one embodiment, the heat transfer layer **34** can be a plate composed of copper or another material that has high thermal conductivity. The heat transfer layer **34** can be between 10 and 400 micrometers thick, although thinner or thicker layers can be used. The heat transfer member **38** can be coupled to the heat transfer layer by a layer of heat-conducting solder **36**. In the illustrated embodiment, the heat transfer member **38** can comprise a material of high thermal conductivity (e.g., copper), which is shaped into a plurality of fins. Other materials or shapes can also be used, such as copper alloys or circular members. Additionally, the heat transfer between the heat transfer member **38** and the surrounding environment can be enhanced by providing a fluid transfer device (e.g., a fan) to move fluid (e.g., air) over and/or through the heat transfer member **38**.

[0030] When a current is passed through the N-type semiconductor elements **22** in series with the P-type semiconductor elements **24**, one junction **28** on one side of the semiconductor elements **22**, **24** is heated and the junction **28** on the other side of the thermoelectric elements **22**, **24** is cooled. That is, when a voltage is applied in one direction in series through the semiconductor elements **22**, **24**, alternating junctions **28** of the N-type semiconductor elements **22** and P-type semiconductor elements **24** will heat and cool respectively. With reference to FIG. 2A, because the junctions **28** of the semiconductor elements **22**, **24** are located alternately on the top and bottom of the device **10**, when a voltage is applied in one direction through the semiconductor elements **22**, **24** the top of the thermoelectric device **10** heats and the bottom of the thermoelectric device **10** cools. When the current direction is reversed, the top of the thermoelectric device **10** is cooled and the bottom is heated. Current can be applied to the device **10** through electrical connectors **40**, which can be electrically coupled one of the junctions **28**.

[0031] As described above, the sensor **50** can be disposed between the semiconductor elements **22**, **24**. The sensor **50** can be configured to determine any of a number of states of operation of the thermoelectric device **10**. In the illustrated embodiment, the sensor **50** can be a temperature sensor, such as a thermistor. As an example, a thermistor with an internal resistance of about **1000 S2** can be used. Other resistances and other sensors that detect different operating states of the

device **10** can also be used, including, but not limited to, thermocouples and resistance thermometers. The sensor **50** can determine the temperature of the thermoelectric device **10** at a point located among the semiconductor elements **22**, **24**. The sensor **50** can be disposed on a conductor tab **28** (e.g., element **52**) between an N-type semiconductor element **22** and a P-type semiconductor element **24**, or can be disposed between any two conductor elements **22**, **24** while mounted or placed on the substrate **32**. In a modified embodiment, the sensor **50** can be disposed between a semiconductor element **22**, **24** and the edge of the substrate **32**.

[0032] With reference back to FIGS. 1A and 1B, the seal **60** is shown surrounding the thermoelectric device **10** between the substrates **32**. In general, the seal **60** is disposed between the two substrates **32**, and surround the plurality of semiconductor elements **22**, **24**. FIG. 2C is a top plan view of a bottom half of a thermoelectric device **10**. As can be seen, the semiconductor elements **22**, **24** can be disposed on the conductor tabs **28** in an alternating pattern. The sensor **50** can be placed on one of the substrates **32** between an N-type thermoelectric element **22** and a P-type thermoelectric element **24**. The wire **52** of the internal sensor **50** can extend through the seal **60**.

[0033] The sensor **50** can have a wire **52** or other communication medium which extends through the seal **60**. The seal **60** can be constructed of any material sufficient to inhibit moisture or other contaminants from entering the thermoelectric device **10**. In some embodiments, the seal **60** can comprise putty. In other embodiments, plastics or epoxy can be used. In one particular embodiment, RTV, a commercially available silicone rubber sealant, can be used. In one embodiment, the seal **60** can extend completely around the perimeter of thermoelectric device **10** to completely enclose the thermoelectric elements **22**, **24** and sensor **50** positioned between the substrate **32**. In certain embodiments, the seal **60** can extend at least partially between the substrates **32** and in between the thermoelectric elements **22**, **24**.

[0034] With reference now to FIG. 2D, another embodiment of the thermoelectric device **10** is illustrated. Unless otherwise described, the components in FIG. 2D are substantially identical to those of FIG. 2C. FIG. 2D illustrates a thermoelectric device **10'** having a sensor **70** that has a substrate footprint greater than the preferred distance between two thermoelectric elements **22'**, **24'**. Accordingly, some of the thermoelectric elements **22'**, **24'** have been removed to accommodate the sensor **50'**. The sensor **50'** can be disposed at any location where a thermoelectric element **22'**, **24'** is disposed between the sensor **50'** and an edge of the substrate **32'**. In the illustrated embodiment, the sensor **50'** provides information through a set of connecting traces **72** etched on the substrate **50'**. In other embodiments, the wire **52** described above can be used. The thermoelectric elements **22'**, **24'** ordinarily disposed at the location of the connecting traces **72** are removed. In the illustrated embodiment, the connecting traces **72** are composed of a metal, such as copper. Other electrically-conductive materials can also be used, such as gold. In the illustrated embodiment, the connecting traces **72** are in communication with the sensor **50'**, which is disposed in substantially the center of the substrate **32'**. The connecting traces **72** extend from the sensor **50'** toward the edge of the substrate **32'**.

[0035] With reference now to FIG. 2D, another embodiment of the thermoelectric device 10 is illustrated. Unless otherwise described, the components in FIG. 2D are substantially identical to those of FIGS. 2C and a prime (') has been added to the number. In the illustrated embodiment, the sensor 70 is disposed between the substrates 32' and conductor elements 28. As illustrated, the connecting traces 72 preferably extend from the sensor 70 towards an edge of the substrate 32' between the conductor elements 28.

[0036] With reference now to FIG. 2E, another embodiment of the thermoelectric device 10 is illustrated. Unless otherwise described, the components in FIG. 2D are substantially identical to those of FIG. 2C a double prime (") has been added to the number. FIG. 2E illustrates a thermoelectric device 10 having a sensor 70 that has a substrate footprint greater than the preferred distance between two thermoelectric elements 22', 24'. Accordingly, some of the thermoelectric elements (not shown) and/or conductor element 28" have been removed to accommodate the sensor 70. The sensor 70 can be disposed at any location where a thermoelectric element (not shown) is disposed between the sensor 70 and an edge of the substrate 32'. In the illustrated embodiment, the sensor 70 provides information through a set of connecting traces 72 etched on the substrate 32'. In other embodiments, the wire 52 described above can be used. The thermoelectric elements (not shown) ordinarily disposed at the location of the connecting traces 72 are removed. In the illustrated embodiment, the connecting traces 72 are composed of a metal, such as copper. Other electrically-conductive materials can also be used, such as gold. In the illustrated embodiment, the connecting traces 72 are in communication with the sensor 70, which is disposed in substantially the center of the substrate 32". The connecting traces 72 extend from the sensor 50" toward the edge of the substrate 32'.

[0037] With reference now to FIG. 3, a climate control system 99 for a seat assembly 100 is shown in combination with a pair of thermoelectric devices 10a, 10b, which can be arranged as described above. In the illustrated embodiment, the seat assembly 100 is similar to a standard automotive seat. However, it should be appreciated that certain features and aspects of the climate control system 99 and seat assembly 100 described herein can also be used in a variety of other applications and environments. For example, certain features and aspects of the system 99 and assembly 100 may be adapted for use in other vehicles, such as, for example, an airplane, a wheel chair, a boat, or the like. Further, certain features and aspects of the system 99 and assembly 100 can also be adapted for use in stationary environments, such as, for example, a chair, a sofa, a theater seat, a mattress, and an office seat that is used in a place of business and/or residence.

[0038] The seat assembly 100 can comprise a seat portion 102 and a back portion 104. The seat portion 102 and back portion 104 can each comprise a cushion 106a, 106b and a plurality of channels 108a, 108b disposed within and/or extending through the cushions 106a, 106b. Each of the channels 108a, 108b can be placed in fluid communication with the climate control system 99 through a conduit 110a, 110b. The conduits 110a, 110b, in turn, are in communication with separate climate control devices 112a, 112b. In the illustrated embodiment, the channels 108a associated with the seat portion 102 are in communication with a different climate control device 112a than the channels 108b in the

back portion. However, in other embodiments, a single climate control device can be in fluid communication with the channels 108a, 108b the seat portion 102 and back portion 104. In other embodiments, multiple climate control devices can be associated with either the seat portion 102 and/or the back portion 104. In some embodiments, the channels 108a, 108b and/or conduits 110a, 110b can include resistive heating elements (not shown).

[0039] In the illustrated embodiment, the climate control devices 112a, 112b can each comprise the thermoelectric device 10a, 10b, which can be configured as described above, and a fluid transfer device 130a, 130b. The fluid transfer device 130a, 130b can be a radial or axial fan, or other device for transferring a fluid. The thermoelectric device 10a, 10b can be disposed between the fluid transfer device 130a, 130b and the conduits 110a, 110b. As described above, the thermoelectric device 10a, 10b can be configured to selectively heat or cool the fluid (e.g., air) delivered by the fluid transfer device 130a, 130b to the seat portion 102 and back portion 104. The fluid transfer device 130a, 130b can be configured to transfer air to the channels 108a, 108b that is drawn past only one side of the thermoelectric device 10a, 10b. Accordingly, the climate control devices 112a, 112b can be configured to alternately supply heated or cooled air 122a, 122b through the plurality of conduits 110a, 110b to the seat 100. The fluid transfer device 130a, 130b can also be used to withdraw air through the conduits 110a, 110b.

[0040] In the illustrated embodiments, each of the thermoelectric devices 10a, 10b include a pair of heat transfer members 38 (not shown in FIG. 3) as described above. The heat transfer members 38 form a waste heat exchanger and a generally opposing main heat exchanger, which can be thermally exposed to the air transferred by the fluid transfer device 130a, 130b. Depending upon the mode of operation, heat can be transferred to the air through the main heat exchanger or withdrawn from the air through the main heat exchanger.

[0041] The climate control devices 112a, 112b can be controlled and operatively connected by an electronic control device 114a, 114b. The electronic control devices 114a, 114b can receive signals from a plurality of input sources 116, 118, 120. In the illustrated embodiment, three input sources are shown, but more or fewer can be used. The electronic control devices 114a, 114b can be operatively connected with each other through an information connection 124. The electronic control devices 114a, 114b can be configured change the operating state of the climate control devices 112a, 112b in response to a control signal or setting. For example, the electronic control devices 114a, 114b can alter the speed at which fluid is transferred by the fluid transfer devices 130a, 130b or the operating state of the thermoelectric devices 10a, 10b to heat or cool the fluid. The sensor 50 (not shown in FIG. 3) disposed in the thermoelectric devices 10a, 10b can impart information through the wire 52a, 52b to the electronic control devices 114a, 114b, thereby allowing the devices 114a, 114b to determine accurately the operating temperature of the climate control devices 112a, 112b. The electronic control devices 114a, 114b can adjust the operation of the climate control devices 112a, 112b based at least in part on information provided by the sensor 50. For example, the electronic control devices 114a, 114b can change the direction or strength of current in the thermoelectric devices 10a, 10b, change the speed of

operation of the fluid transfer device **130a**, **130b**, and/or shut down the devices **10a**, **10b** if there is a malfunction.

[0042] With reference now to FIG. 4, an assembly **200** is shown in combination with a thermoelectric device **210**, which can be arranged according to the embodiment described above. In the illustrated embodiment, the assembly **200** defines a cavity **201**, which can be enclosed (e.g., via a removable or retractable door or top). In a modified embodiment, the assembly **200** can device one or more holders **202** for containers (e.g., a cup holder). In either embodiment, the assembly **200** preferably includes one or more conductive elements or material **204** that surrounds at least partially cavities **201**, **202** so as to cool (or heat) articles positioned therein.

[0043] The conductive material or elements **204** can be conductively coupled to the one side of the thermoelectric device **210** while the other side of the device **210** can be conductively coupled to a heat exchanger **212** positioned within a duct **206**. A fluid transfer device **208** can be used to pump air through the heat exchanger **212**. In this manner, the thermoelectric device **210** can be used to withdraw heat from the cup holder **203** or cavity **201** to cool a container or article positioned therein and/or transfer heat to the cup holder **203** or cavity **201** to heat a container positioned

[0044] FIG. 5 illustrates a modified embodiment of the assembly **230**. As described above, the assembly can include a cavity **301**, which can be enclosed (e.g., via a removable or retractable door or top). In a modified embodiment, the assembly **300** can include one or more holders **303** for containers (e.g., a cup holder). Insulation **304** can be provided to insulate the cavity **301** or cup holder **303**. In this embodiment, the thermoelectric device **310** has a first side coupled to a first heat exchanger **313** and a second side coupled to a second heat exchanger **312**. Each heat exchanger **313**, **312** is positioned within a duct **314**, **306**. Each duct **313**, **306** can be in communication with a fluid transfer device **308** or share a common fluid transfer device (not illustrated). The air on the first side of the device **313** is directed into the cavity **201**, **202**. In this manner, conditioned (e.g., hot or cold) air can be directed into the assembly **300** to cool and/or heat objects and article positioned therein. As shown by the dashed lines, in one embodiment, the air delivered to the cavity **301**, **302** can be re-circulated to the fluid transfer device **308** through a recirculation passage **316**.

[0045] Various components are described as being “operatively connected” to the control unit. It should be appreciated that this is a broad term that includes physical connections (e.g., electrical wires or hard wire circuits) and non-physical connections (e.g., radio or infrared signals). It should also be appreciated that “operatively connected” includes direct connections and indirect connections (e.g., through additional intermediate device(s)).

[0046] Although this invention has been disclosed in the context of certain preferred embodiments and examples, it will be understood by those skilled in the art that the present invention extends beyond the specifically disclosed embodiments to other alternative embodiments and/or uses of the invention and obvious modifications and equivalents thereof. In addition, while the number of variations of the invention have been shown and described in detail, other modifications, which are within the scope of this invention, will be readily apparent to those of skill in the art based upon this disclosure. It is also contemplated that various combi-

nations or subcombinations of the specific features and aspects of the embodiments may be made and still fall within the scope of the invention. Accordingly, it should be understood that various features and aspects of the disclosed embodiments can be combined with, or substituted for, one another in order to perform varying modes of the disclosed invention. Thus, it is intended that the scope of the present invention herein disclosed should not be limited by the particular disclosed embodiments described above, but should be determined only by a fair reading of the claims.

1. (canceled)

2. A thermoelectric device comprising:

a first substrate and a second substrate spaced apart from each other to form a gap;

a plurality of semiconductor elements disposed between the first and second substrates within the gap, the plurality of semiconductor elements comprising a first group of semiconductor elements having a first set of electrical properties and a second group of semiconductor elements having a second set of electrical properties;

a first set of electrical conductors disposed between the plurality of semiconductor elements and the first substrate and a second set of electrical conductors disposed between the plurality of semiconductor elements and the second substrate, the first set of electrical conductors and the second set of electrical conductors arranged so the plurality of semiconductor elements are electrically coupled to each other in series with the first and second groups of semiconductor elements in an alternating arrangement,

wherein the first group of semiconductor elements comprises N-type semiconductor elements and wherein the second group of semiconductor elements comprises P-type semiconductor elements, each electrical conductor being coupled to at least one N-type semiconductor element and at least one P-type semiconductor element to form a Peltier circuit, and

wherein the first set of electrical conductors are coupled to the first substrate, and the second set of electrical conductors are coupled to the second substrate;

a sensor disposed between the first and second substrates at a location spaced from a peripheral edge of the first substrate or the second substrate, wherein the sensor is located adjacent to at least two semiconductor elements and is located between the first and second substrates; and

a seal extending along at least a part of the peripheral edge of the first or second substrate, the seal extending between the first and second substrates from the peripheral edge of the first or second substrate to the other substrate,

wherein at least a portion of the seal is positioned substantially within the peripheral edge of the first or second substrate,

wherein the plurality of semiconductor elements are arranged so that at least some of the semiconductor elements establish an outer boundary along a periphery of the semiconductor elements,

wherein the plurality of semiconductor elements positioned along the outer boundary surround at least one row of interior semiconductor elements, and

wherein the sensor is disposed adjacent at least one interior semiconductor elements and adjacent at least one semiconductor element positioned along the outer boundary.

3. The thermoelectric device of claim 2, the seal extends in between at least two of the plurality of semiconductor elements.

4. The thermoelectric device of claim 2, wherein the seal is not in contact with the sensor.

5. The thermoelectric device of claim 2, wherein the sensor is located equivalent of at least one row of semiconductor elements away from any portion of the peripheral edge of the first or second substrate.

6. The thermoelectric device of claim 2, wherein the sensor is enclosed by at least one row of semiconductor elements on all sides of the sensor such that the plurality of semiconductor elements surrounds the sensor.

7. The thermoelectric device of claim 2, wherein the sensor is at least one of a temperature sensor, a thermistor, or a thermocouple.

8. The thermoelectric device of claim 2, wherein the sensor is disposed, with respect to the peripheral edge of the first or second substrate, at substantially the center of one of the first and second substrates.

9. The thermoelectric device of claim 2, wherein the seal completely encloses all of the plurality of semiconductor elements positioned between the first and second substrates.

10. A thermoelectric device comprising:

a pair of opposing substrates, each substrate having a peripheral edge and a face that generally opposes a face of the other opposing substrate;

a plurality of semiconductor elements are positioned between the opposing faces of the opposing substrates, the plurality of semiconductor elements comprises at least two groups of dissimilar semiconductor elements, the plurality of semiconductor elements electrically coupled in series by conductor elements arranged so the two groups of dissimilar semiconductor elements are connected in an alternating pattern, the conductor elements being coupled to the opposing substrates, to form a Peltier circuit,

wherein at least some of the semiconductor elements form an outer peripheral boundary that defines an interior region within which all remaining semiconductor elements are positioned; and

a sensor positioned between the pair of opposing substrates at a location spaced from the peripheral edges of the opposing substrates, the sensor being disposed within the interior region and between the plurality of semiconductor elements positioned within the interior region,

wherein the sensor is located equivalent of at least one row of semiconductor elements away from any portion of the peripheral edges of the opposing substrates.

11. The thermoelectric device of claim 10, further comprising a seal extending along a side of one of the peripheral edges of the opposing substrates.

12. The thermoelectric device of claim 11, wherein the seal extends at least partly between the opposing substrates.

13. The thermoelectric device of claim 11, wherein the seal extends between at least two of the plurality of semiconductor elements.

14. The thermoelectric device of claim 11, wherein the seal is positioned substantially within the peripheral edges of the opposing substrates.

15. The thermoelectric device of claim 10, wherein the sensor is enclosed by at least one row of semiconductor elements on all sides of the sensor such that the plurality of semiconductor elements surrounds the sensor.

16. A thermoelectric system comprising:

a first substrate and a second substrate spaced apart from each other;

a plurality of semiconductor elements disposed between the first and second substrates, the semiconductor elements comprising a plurality of N-type semiconductor elements and a plurality of P-type semiconductor elements;

a first set of conductor tabs disposed between the plurality of semiconductor elements and the first substrate;

a second set of conductor tabs disposed between the plurality of semiconductor elements and the second substrate, the first set of conductor tabs and the second set of conductor tabs being arranged so the plurality of semiconductor elements are electrically coupled to each other in series,

wherein the N-type semiconductor elements and the P-type semiconductor elements are electrically coupled to each in an alternating arrangement,

wherein each conductor tab is coupled to one N-type semiconductor element and one P-type semiconductor element to form a Peltier circuit,

wherein the semiconductor elements are located within an area generally bounded by an outer periphery of the first or second substrate,

wherein the semiconductor elements are either peripheral semiconductor elements or interior semiconductor elements,

wherein the peripheral semiconductor elements comprise semiconductor elements that are oriented along the outer periphery, and

wherein the peripheral semiconductor elements define an interior region, wherein all interior semiconductor elements are positioned within the interior region within the peripheral semiconductor elements; and

a sensor disposed between the first and second substrates at a location within the interior region spaced from the outer periphery equivalent of at least one row of semiconductor elements,

wherein the sensor is positioned adjacent to at least one interior semiconductor element, and

wherein the sensor is generally enclosed from ambient environment.

17. The thermoelectric system of claim 16, wherein the sensor is at least partially enclosed from ambient environment via at least one of a putty, a plastic, an epoxy, or a rubber material.

18. The thermoelectric system of claim 17, wherein the material extends along at least a part of the outer periphery of the first or second substrate.

19. The thermoelectric system of claim 18, wherein the material extends at least partly between the first and second substrates.

20. The thermoelectric system of claim 19, wherein the material comprises a seal extending between the first and second substrates.

21. The thermoelectric system of claim 20, wherein the material extends between at least two of the plurality of semiconductor elements.

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